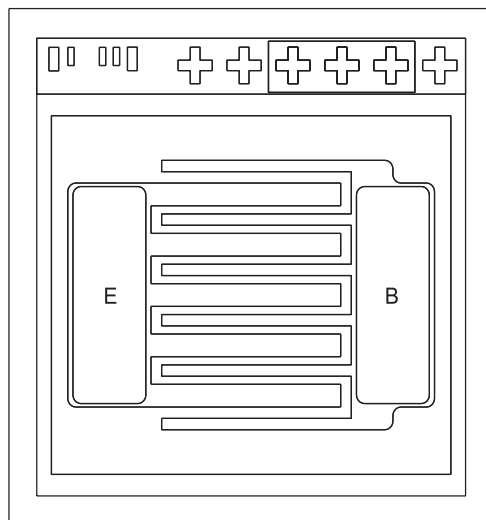


**PROCESS DETAILS**

Process	EPITAXIAL PLANAR
Die Size	30 x 30 MILS
Die Thickness	9.0 MILS
Base Bonding Pad Area	4.4 x 12.5 MILS
Emitter Bonding Pad Area	4.4 x 12.5 MILS
Top Side Metalization	Al - 30,000Å
Back Side Metalization	Au - 12,000Å

**GEOMETRY**



BACKSIDE COLLECTOR

R1

**GROSS DIE PER 4 INCH WAFER**

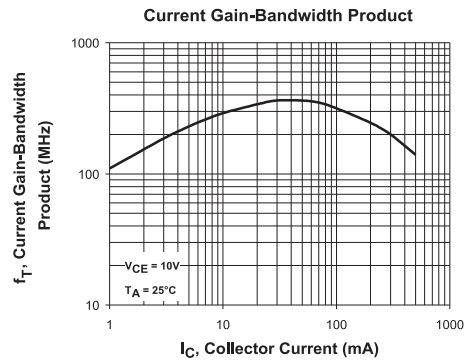
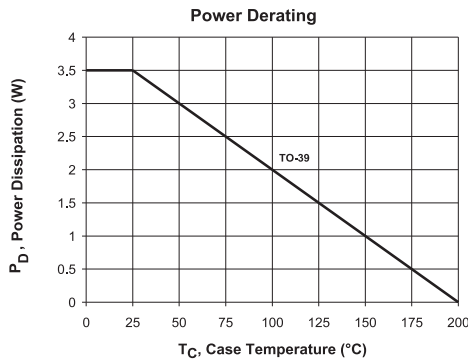
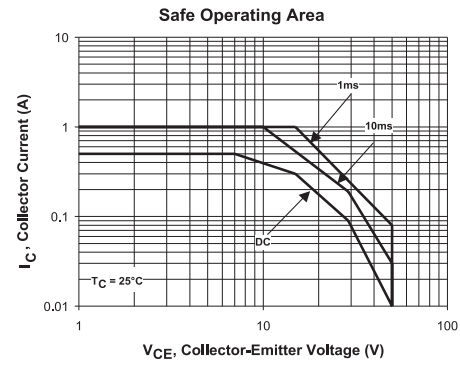
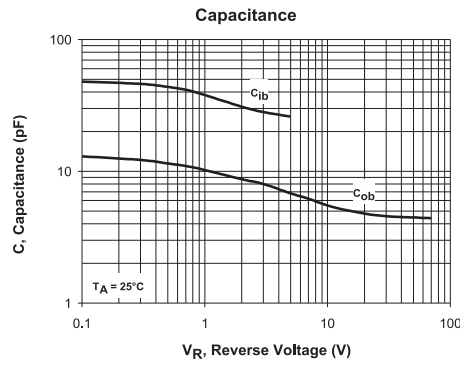
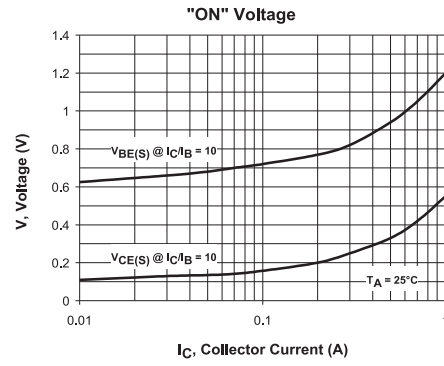
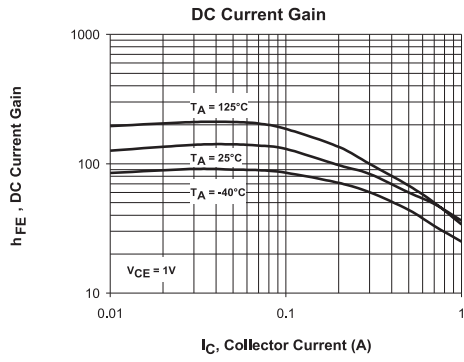
12,550

**PRINCIPAL DEVICE TYPES**

2N3725  
2N3725A  
MPQ3725  
MPQ3725A

145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
Fax: (631) 435-1824  
www.centrasemi.com

R2 (1-August 2002)



145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
Fax: (631) 435-1824  
www.centralsemi.com

R2 (1-August 2002)